

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Bernd SZYSZKA et al. Group Art Unit: 1795  
Appln. No. : 10/583,124 Examiner: R. G. McDonald  
I.A. Filed : November 29, 2004 Confirmation No.: 1797  
For : METHOD AND DEVICE FOR MAGNETRON SPUTTERING

**AMENDMENT UNDER 37 C.F.R. 1.116**

Commissioner for Patents  
U.S. Patent and Trademark Office  
Customer Service Window, Mail Stop **AF**  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

Responsive to the final Office Action of December 17, 2009, the period for response extending until March 17, 2010, reconsideration of this action and allowance of all the claims of the present application are respectfully requested and are now believed appropriate in view of the following amendments and remarks.

*Amendments to the Claims* are reflected in the listing of claims which begins on page 2 of this paper.

*Remarks* begin on page 7 of this paper.